

Mass Flowmeters and Controllers

Brooks Model 4800 Series mass flowmeters and controllers, which offer a broad flow range and compact size, are engineered with a MEMS-based thermal sensor for exceptionally fast response to changes in gas flow rate. The sensor achieves these fast response rates by allowing the gas to flow directly across the sensor. The series can handle measurement and control of many common gases including air, N₂, O₂, Ar, He, H₂, CO₂, CO, N₂O, CH₄, CH₃H₆, and C₃H₈.

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www.emersonprocess.com

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